

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|              |   |             |            |
|--------------|---|-------------|------------|
| Applicant :  | Takeshi Nakamura et al.                   | Art Unit :  | 3729       |
| Serial No. : | 10/598,469                                | Examiner :  | Minh Trinh |
| Filed :      | May 17, 2007                              | Conf. No. : | 5820       |
| Title :      | MULTILAYER SUBSTRATE MANUFACTURING METHOD |             |            |

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 23, 2009

Please amend the above-identified application as follows: